

Docket No. 740819-537

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	
Takeshi YAMASHITA et al.)	Group Art Unit: 1765
Serial No. 09/826,098)	Examiner: Kin Chan Chen
Filed: April 5, 2001)	Confirmation No. 2729
For: DRY ETCHING METHOD, FABRICATION METHOD FOR SEMICONDUCTOR DEVICE AND)	Date: May 13, 2004

RESPONSE TO NOTICE REGARDING DRAWINGS

Mail Stop <u>Issue Fee</u> Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

DRY ETCHING APPARATUS

Sir:

In response to the Notice Regarding Drawings dated April 26, 2004, attached hereto are sixteen (16) sheets formal drawings, Figs. 1A -17 for filing in the subject application.

Respectfully submitted,

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UNITED STATES PATENT AND TRADEMARK OFFICE

UNDER SECRETARY OF COMMERCE FOR INTELLECTUAL PROPERTY AND DIRECTOR OF THE UNITED STATES PATENT AND TRADEMARK OFFICE

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FIRST NAMES APPLICANT YAMASHITA, TAKESHI ATTORNEY DOCKET NUMBER 740819-537

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Art Unit 1765

Paper Number

Date Mailed: 04-26-04

Notice Regarding Drawings

Corrected drawings for the above-identified application, received in the USPTO on 8-27-03 are still not acceptable for the reason(s) identified on the attached PTO-948. Applicant is given one opportunity to correct the informalities within a two-month time period from the mailing date of this Notice. THIS TIME PERIOD IS NOT EXTENDABLEUNDER EITHER 37 CFR 1.136(a) OR 1.136(b). Failure to take corrective action within the set period will result in abandonment of the application.

ATTACHMENT: PTO-948 Notice of Draftsperson's Patent Review

RETURN CORRECTED DRAWINGS TO:

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